



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76863

Toshinobu OGATSU

Appln. No.: 10/694,841

Confirmation No.: 2499

Group Art Unit: 2851

Filed: October 29, 2003

Examiner: Rodney Evan FULLER

For: WAFER SUPPORT DEVICE AND A WAFER SUPPORT METHOD

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance dated August 19, 2005, please amend the above-identified application as follows on the accompanying pages.

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